Electron diffraction CIF dictionary

CIF ED HEAD

This category is the Head category for an extension dictionary used for crystallographic structure determination using electron diffraction.

CHEMICAL

_chemical.absolute_configuration

_chemical_absolute_configuration

Necessary conditions for this assignment are given by Flack, H. D. & Bernardinelli, G. (1999). *Acta Cryst.* A**55**, 908–915. Flack, H. D. & Bernardinelli, G. (2000). *J. Appl. Cryst.* **33**, 1143–1148.

The data value must be one of the following:

rm	'reference molecule' Absolute configuration established by the struc-
	ture determination of a compound containing a chiral reference
	molecule of known absolute configuration.

ad 'anomalous dispersion' Absolute configuration established by a-d effects in diffraction measurements on the crystal.

dyn Absolute configuration determined directly from dynamical refinement.

'rm + ad' Absolute configuration established by the structure determination of a compound containing a chiral reference molecule of known absolute configuration and confirmed by a-d effects in diffraction measurements on the crystal.

'synthetic' Absolute configuration has not been established by anomalous-dispersion effects in diffraction measurements on the crystal. The enantiomer has been assigned by reference to an unchanging chiral centre in the synthetic procedure.

unk 'unknown' No firm chemical or a-d evidence for an assignment is available. An arbitrary choice of enantiomer has been made.

. Inapplicable.

syn

COMPUTING

_computing.sample_tracking

(Text

Reference to software used to track the position of a sample with respect to the diffraction source beam. Typically used in 3D electron diffraction. More details of the tracking method may be provided in _diffrn_measurement.sample_tracking_method.

Example: 'PyFast-ADT (Santucci, 2024)'

DIFFRN

_diffrn.precession_semi_angle

(Real;

Angle at the sample of the tilt from the normal direction of a radiation beam moved in a precessional scan.

The permitted range is $0.0 \to \infty$.

_diffrn.precession_semi_angle_su

 $(Real; \circ)$

Standard uncertainty of _diffrn.precession_semi_angle.

DIFFRN_DETECTOR

_diffrn_detector.distance_sample

(Real; mm)

Mean distance in millimetres from the diffracting sample to the detector. Appropriate for instrument geometries where the detector is fixed or maintained at a constant distance from the diffraction target. More general geometries and provision for adjusting the instrument geometries between or during scans are handled by the imgCIF dictionary.

The permitted range is $0.0 \rightarrow \infty$.

The electron diffraction camera constant calibration factor.

Reference: Millette, J. (1987). The Microscope, 35, 107–117.

The permitted range is $0.0 \to \infty$.

DIFFRN_MEASUREMENT

_diffrn_measurement.method_precession

Yes or no flag indicating if the radiation beam illuminates the sample at an angle that is rotated about a precession axis.

The data value must be one of the following:

yes Precession method is used.
y Abbreviation for 'yes'.
no Precession method is not used.
n Abbreviation for 'no'.

_diffrn_measurement.rotation_mode

(Code)

(Code)

Code describing the technique used to sample as completely as possible the accessible range of reciprocal space.

The data value must be one of the following:

rotation The detector records diffracted intensities continuously while the sample is rotated.

Stepwise The detector records diffracted intensities while the sample is stationary and the beam is either steady or performing a defined motion, typically precessing around a conical surface normal to the sample (precession electron diffraction).

_diffrn_measurement.sample_tracking (Code)

Yes or no flag indicating if a tracking method to follow the crystal was used in the data acquisition. Typically used to track very small crystals in electron diffraction experiments.

The data value must be one of the following:

yes A crystal tracking method is used.

y Abbreviation for 'yes'.

no A crystal tracking method is not used.

n Abbreviation for 'no'.

_diffrn_measurement.sample_tracking_method

(Text)

Description of the method used to follow the crystal during data collection.

Example: 'Electron-beam tracking by PyFast-ADT'

DIFFRN_RADIATION

diffrn radiation.illumination mode

(Code)

Code describing the optical configuration of the incident beam at the sample. For electron diffraction, parallel illumination is the normal mode in transmission electron microscopy (TEM), convergent-beam in scanning transmission electron microscopy (STEM).

The data value must be one of the following:

convergent Convergent-beam illumination

Parallel illumination parallel

DIFFRN_SOURCE

_diffrn_source.convergence_angle

(Real; °)

The angle of convergence of the source beam (for example in convergent-beam electron diffraction). The convergence angle is the angular spread of the cone of illumination (i.e. 2α , where the semi-angle α is measured from the axis defining the beam direction)

The permitted range is $0.0 \rightarrow \infty$.

diffrn source.ed diffracting area selection

Enumerated code for the technique in electron diffraction used to select the region of the sample from which the diffraction pattern is obtained.

The data value must be one of the following:

Diffraction region selected by the size of the probe (= beam) probe

Selected-area electron diffraction SAED

diffrn source.size (Text)

_diffrn_source_size

Description of the collimated source beam as viewed from the sample.

Examples: '8mm x 0.4 mm fine-focus', 'broad focus'.

'300 nm electron beam in NBED (nano-beam electron diffraction)',

'1 micrometre aperture size in SAED (selected-aperture el. diffr.)'

EXPTL_CRYSTAL

_exptl_crystal.mosaic_block_size (Real; Å)

Isotropic and resolution-independent term representing the average size of mosaic domains in the crystal specified in ångströms. Larger size indicates better ordered crystals.

The permitted range is $0. \to \infty$.

_exptl_crystal.mosaic_block_size_su (Real; Å)

Standard uncertainty of _exptl_crystal.mosaic_block_size.

_exptl_crystal.mosaic_method

How parameters derived from the spot shape (such as mosaic block size and rotation, beam divergence, and crossfire) and their errors were estimated. This can be a written description or a citation to a specific software package that determined these parameters.

Example: 'Determined from rocking curve.'

_exptl_crystal.mosaicity

(Real; °)

Isotropic approximation of the distribution of mis-orientation angles specified in degrees of all the mosaic domain blocks in the crystal, represented as a standard deviation. Here, a mosaic block is a set of contiguous unit cells assumed to be perfectly aligned. Lower mosaicity indicates better ordered crystals. See for example: Nave, C. (1998). Acta Cryst. D54, 848–853. Note that many software packages estimate the mosaic rotation distribution differently and may combine several physical properties of the experiment into a single mosaic term. This term will help fit the modelled spots to the observed spots without necessarily being directly related to the physics of the crystal itself.

The permitted range is $0. \to \infty$.

_exptl_crystal.mosaicity_su

Standard uncertainty of _exptl_crystal.mosaicity.

REFINE

_refine.diffraction_theory

(Code)

(*Real*; °)

A code describing the approach to the calculation of the diffracted intensities. In the kinematical approximation, interactions of diffracted waves with matter are neglected, and integrated intensities of the Bragg reflections are proportional to the square of the modulus of the structure factor. In the dynamical calculation, interactions between diffracted waves are taken into account, and the proportionality of the intensities and the structure factors is not preserved.

The data value must be one of the following:

dynamical Interactions between diffracted waves and matter are taken into account when calculating the amplitudes of the

diffracted beams.

kinematical Interactions between diffracted waves and matter are ignored when calculating the amplitudes of diffracted beams.

refine.diffraction theory details

Details needed to characterize the approach to the calculation of the diffracted intensities, such as a description of the parameters that were refined dynamically.

REFINE_DIFF

_refine_diff.potential_max

 $(Real; e Å^{-1})$

Maximum electrostatic potential value in a difference Fourier map.

_refine_diff.potential_max_su (Real; e $Å^{-1}$) Standard uncertainty of _refine_diff.potential_max.

_refine_diff.potential_min (Real; e $Å^{-1}$)

Minimum electrostatic potential value in a difference Fourier map.

_refine_diff.potential_min_su (*Real*; e $Å^{-1}$) Standard uncertainty of _refine_diff.potential_min.

_refine_diff.potential_RMS

Root mean square electrostatic potential value in a difference Fourier map. This value is measured with respect to the arithmetic mean potential and is derived from summations over each grid point in the asymmetric unit of the cell. This quantity is useful for assessing the significance of *_min and *_max values, and also for defining suitable contour levels.

refine diff.potential RMS su (Real; e Å $^{-1}$) Standard uncertainty of _refine_diff.potential_RMS.

REFINE_LS

_refine_ls.abs_structure_z-score

(Real)

The z-score is a measure of confidence in an absolute structure determination as described by Klar *et al.* (2023), based on the method of Le Page *et al.* (1990). For centrosymmetric structures, the only permitted value, if the data item is present, is 'inapplicable', represented by '.'

References: Klar, P. B. *et al.* (2023). *Nature Chem.* **15**, 848–855. Le Page, Y., Gabe, E. J. & Gainsford, G. J. (1990). *J. Appl. Cryst.* **23**, 406–411.

_refine_ls.sample_shape_details

(Text)

Additional details describing the sample thickness when calculated during dynamical refinement where this cannot be defined completely by the formula given in _refine_ls.sample_shape_expression.

Reference: Palatinus, L., Petricek, V. & Correa, C. A. (2015). *Acta Cryst.* A**71**, 235–244.

_refine_ls.sample_shape_expression

(Text)

Formula for the sample thickness distribution when the sample thickness is considered during dynamical refinement.

Reference: Palatinus, L., Petricek, V. & Correa, C. A. (2015). *Acta Cryst.* A**71**, 235–244.

 $F(\t) = 1 - (1 - \t^2)^1/2$

; (The cumulative distribution function in terms of the reduced thickness τ of a sample treated as a cylinder. $\tau = t/t_m$, where t is the thickness at the point illuminated and t_m the maximum thickness of the cylinder (*i.e.* its diameter).)

_refine_ls.sample_thickness

(Real; nanometres)

The refined sample thickness as determined by dynamical refinement

Reference: Palatinus, L., Petricek, V. & Correa, C. A. (2015). *Acta Cryst.* A**71**, 235–244.

The permitted range is $0. \to \infty$.

Example: '35 (2)'

_refine_ls.sample_thickness_su

(Real; nanometres)

Standard uncertainty of _refine_ls.sample_thickness.